

<b>Notice of References Cited</b>	Application/Control No. 10/820,302	Applicant(s)/Patent Under Reexamination BORGOS ET AL.	
	Examiner Scott A. Hughes	Art Unit 3663	Page 1 of 1

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Donias, et al. "Curvature of Oriented Patterns: 2-D and 3-D Estimation from Differential Geometry." IEEE 1998
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.